

MAY 21 2007

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Joanna Schmit et al. DOCKET NO.: 121892.00002

SERIAL NO.: 10/759,686 FILED: 01/16/2004

EXAMINER: Andrew Hwa Lee ART UNIT: 2877

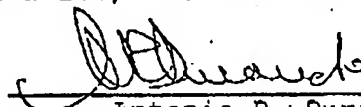
TITLE: Measurement of Object Deformation with Optical Profiler

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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CERTIFICATE OF TRANSMISSION

I hereby certify that on this 21st day of May, 2007, this correspondence is being transmitted via facsimile (at 571-273-8300) to the United States Patent and Trademark Office, Att.: Examiner Andrew Hwa Lee, Art Unit 2877.


Antonio R. Durando

TO THE COMMISSIONER FOR PATENTS
RESPONSE TO FINAL OFFICE ACTION

Dear Sir:

This is in reply to the Office Action dated February 28, 2007, for which a three-month shortened statutory period for response was set to expire on May 28, 2007.